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**MAR 21 2008**

Docket No.: 1293.1966

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of:

Jung-Wan KO et al.

Application No. 10/663,981

Group Art Unit: 2627

Confirmation No. 1954

Filed: September 17, 2003

Examiner: Jorge L. Ortiz Criado

For: METHOD OF AND APPARATUS FOR MANAGING DISC DEFECTS IN DISC, AND  
DISC ON WHICH DEFECTS ARE MANAGED

**LETTER TO THE EXAMINER REQUESTING RECOGNITION OF TIMELY FILED REQUEST  
FOR CONTINUED EXAMINATION (RCE)**

Commissioner for Patents  
PO Box 1450  
Alexandria, VA 22313-1450

Sir:

Further to a routine review of the Patent Application Information Retrieval (PAIR) system, it appears that the system has not been updated to reflect the filing of an RCE on February 25, 2008. A copy of the RCE is in the image file wrapper and is not again included. In order to ensure timely examination, it is respectfully requested that the status be updated to reflect the filing of the RCE.

Respectfully submitted,

STEIN, MCEWEN & BUI, LLP

Date: March 21, 2008

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